



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:		)	
		:	Examiner: K. Gutierrez
YOSHIKAZU MIYAJIMA		)	
		:	Group Art Unit: 2851
Application No.: 10/647,376		)	
		:	
Filed: August 26, 2003		)	
		:	
For:	REFLECTION MIRROR	)	
	APPARATUS, EXPOSURE	:	
	APPARATUS AND DEVICE	)	
	MANUFACTURING METHOD	:	May 15, 2006

## **Mail Stop RCE**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **AMENDMENT**

Sir:

In response to the final Official Action mailed February 15, 2006, the Examiner is respectfully requested to consider and enter the following amendments.